

Case No. 02GR102454481

MS PATENT APPLICATION
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DATE OF DEPOSIT: October 20, 2003

NAME: Justin Goree

SIGNATURE: Justin Goree

22141 U.S. PTO
10/689528
102003

Transmitted herewith for filing is the patent
application of:

Inventors: **Yvon GRIS**

For: **PROCESS AND INSTALLATION FOR DOPING AN ETCHED PATTERN OF RESISTIVE
ELEMENTS**

Enclosed are:

- ☒ Patent Application: 19 pages, 14 claims
2 sheets of drawings
The suggested drawing figure to be published is FIG. 1.
A Preliminary Amendment.
Citation Under 37 CFR 1.97 and PTO-1449.
A certified copy of the French application.
Assignee info:
Name: STMicroelectronics SA
Address: 29, boulevard Romain Rolland, F-92120 Montrouge, France
Country of Incorporation: France
☒ Applicant claims priority benefit to the following foreign application(s):
Country: France
Application No.: 0213011
Filing Date: October 18, 2002

The Declaration and Filing Fee are **NOT ENCLOSED**.

- ☒ Name, Address and Citizenship of Inventor(s) is as follows:

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- ☒ **PLEASE ADDRESS CORRESPONDENCE TO ATTORNEY OF RECORD: CHRISTOPHER F. REGAN**

- ☒ Associate this file with Customer No. 27975.



PATENT TRADEMARK OFFICE

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Date: October 20, 2003

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